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TRANSMITTAL OF INFORMATION DISCL (Under 37 CFR 1.97(b) or 1.9	111	Docket No. OKI.201						
In Re Application O: Takayoshi sawayama								
Serial No. 7 illing Date 1/5/2001	Examiner	Group Art Unit						
Title: PLASMA ETCHING APPARATUS								
Title: PLASMA ETCHING APPARATUS								
Address to:  Commissioner for Patents P.O. Box 1450  Alexandria, VA 22313-1450								
37	CFR 1.97(b)							
1.   The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.								
37	CFR 1.97(c)							
2.   The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:								
☐ the statement specified in 37 CFR 1.97(e);								
OR								
★ the fee set forth in 37 CFR 1.17(p).								

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TRANSMITTAL OF INFORMATION DISCLO	Docket No.		
(Under 37 CFR 1.97(b) or 1.9	7(c))	OKI.201	
In Re Application Takayoshi Sawayama			
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Serial No. 1/5/2001		Group Art Unit	
03/734,277	Luz L. Alejandro	1763	
PLASMA ETCHING APPARATUS			
(Only complete if Applicant ele	ment of Fee ects to pay the fee set forth in 37 CFR 1. ached. redit Deposit Account No. 50-0		
as described below.	Teal Deposit Account No. 50-0	238	
☑ Charge the amount of \$180.00			
Credit any overpayment.			
Charge any additional fee required.			
Certificate of Transmission by Facsimile*	Certificate of Mailing by	First Class Mail	
I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (F:  (Date)	I certify that this document and	fee is being deposited he U.S. Postal Service 7 C.F.R. 1.8 and is for Patents, P.O. Box	
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Signature	Signature of Person Ma.	iling Correspondence	
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Typed or Printed Name of Person Signing Certificate	Typed or Printed Name of Pers	on Mailing Certificate	
*This certificate may only be used if paying by deposit account.  Signature  William S. Francos (Reg. No. 38,456)  VOLENTINE FRANCOS, P.L.L.C.	Dated: March 30, 2004		
12200 Sunrise Valley Drive			
Suite 150			
Reston, VA 20191			
(703) 715-0870			
CC:			

Appl. No. 09/754,277 Submission

N THE MITED STATES

PATENT AND TRADEMARK OFFICE

Appl. No.: 09/754,277

Applicant(s): Takayoshi Sawayama

Filed: January 5, 2001

TC/A.U.: 1763/1700

Examiner: Luz L. Alejandro Mulero

Atty. Docket: OKI.201

Title: PLASMA ETCHING APPARATUS

CERTIFICATE OF MAILING OR TRANSMISSION

I certify that this correspondence is being:

[ X ] deposited with the U.S. Postal Service with sufficient postage as firstclass mail in an envelope addressed to the Commissioner for Patents

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[ ] transmitted by facsimile to the U.S. Patent and Trademark Office at

On: March 30, 2004

By Michelle Welgas

SUBMISSION OF SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Enclosed please find herewith 4 additional references to be considered by the Examiner in the above captioned application, and a copy of the Examiner's Comments issued by the Japanese Patent Office.

In the event that there are any outstanding matters remaining in the present application, the Examiner is invited to contact William S. Francos, Esq. (Reg. No. 38,456) at (610) 375-3513 to discuss these matters.

If necessary, the Commissioner is hereby authorized in this, concurrent, and further replies to charge payment or credit any overpayment to Deposit Account Number 50-0238 for any additional fees under 37 C.F.R. §1.16 or under 37 C.F.R. §1.17.

Respectfully submitted on behalf of:

Oki Electric Industry Co., Ltd.

William S. Francos, Esq.

Reg. No. 38,456

Date: March 30, 2004

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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Transl YES	
		11-297672	29.10.1999	JP (with English Abstract)			TES	NO
				or (with English ribstract)				
	_	07-078769	20.03.1995	JP (with English Abstract)				
		10-270426	09.10.1998	JP (with English Abstract)				
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		10-112400	28.04.1998	JP (with English Abstract)				
		2000-225686	06.11.2003	Exam. Comm. from JP O.A.				
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				OTHER DOCUMENTS (Including A	uthor, Title, D	ate, Pertinent Pa	ges, Etc.)	
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Docket Number (Optional)

Application Number